

28/5/# CC Phr

503.39864X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

Toshiya SATOH et al.

Serial No.:

09/809,181

Filed:

March 16, 2001

For:

SEMICONDUCTOR DEVICE AND MANUFACTURING

METHOD FOR HIGH RELIABILITY AND PRODUCTION YIELD RATE WITH MINIMAL DAMAGE DUE TO APPLICATION OF

MECHANICAL STRESS AND THERMAL STRESS

Group:

2815

Examiner:

Jose R. Diaz

RESPONSE TO OUTSTANDING OFFICE ACTION

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

August 19, 2004

Sir:

In response to the Office Action (Paper No. 20040315) dated on March 25,

2004, please amend the above-identified application as follows.

Listing of the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.